

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	10562265			
<b>Filing Date:</b>	24-May-2006			
<b>Title of Invention:</b>	Method for growing thin nitride film onto substrate and thin nitride film device			
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<b>Filer:</b>	Marvin Jay Spivak/Sirdley Taborga			
<b>Attorney Docket Number:</b>	283485US0PCT			
Filed as Large Entity				
<b>U.S. National Stage under 35 USC 371 Filing Fees</b>				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
<b>Post-Allowance-and-Post-Issuance:</b>				
<b>Extension-of-Time:</b>				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
Request for continued examination	1801	1	810	810
<b>Total in USD (\$)</b>				<b>810</b>